Table of Contents

Foreword	Page iii
Officers and Committee Chairmen	v
Founder Members	
	v :
Symposium Notes	xi
TECHNICAL PROGRAM	
FUNDAMENTAL BASIS OF VACUUM TECHNIQUES	
Outgassing Characteristics of Various Materials—D. J. Santeler	1
The Application of Ultra-high Vacuum Techniques to Controlled Thermonuclear Devices—D. J. Grove	9
Trapping of Noble Gas Ions and the Re-emission of the Trapped Atoms from Nickel and Molybdenum—J. H. Carmichael and J. S. Knoll	18
Diffusion Pump Speed Measurements at Very Low Pressures—A. A. Landfors and M. H. Hablanian	22
The Kinetics of the Adsorption of Nitrogen on Barium Getters—P. Della Porta and F. Ricca	25
The Evaporation of Various Alloys at High Temperature in vacuo—W. A. Blonn	30
Mechanism of Evolution of Gases from Liquid Metal under Vacuum—A. M. Samarin and R. A. Karasev	35
A Simple Formula for the Pressure-Time Dependence During the Evacuation of Vacuum Systems—Th. Kraus	38
APPLIED SCIENCE AND RESEARCH	
Vacuum System for the Cambridge Electron Accelerator—R. L. Hall	41
Theory of Dissimilar Tubular Seals of Glass, Ceramics, and Metals for Critical Applications—G. Lewin and R. Mark	
Simple Outgassing Determinations Aid High Temperature Vacuum Brazing— E. G. Huschke Jr.	50
Electron Diffraction Studies of Structure Changes in Vacuum Deposited Films—R. Thun and G. Hass	58
Preparation of Targets for Accelerators—B. I. Massey	72

Table of Contents

Optical Properties of Some Ferromagnetic Films—J. R. Holmes, A. Rosen and F. McClung	76
New Design of Mechanical Vacuum Pumps—A. Lorenz	7 9
The Effect of Rotational Speed on the Performance of a Roots Blower— E. A. Winzenburger	83
An Electron Bombardment Furnace for the Production of Vacuum-melted Metals —E. S. Candidus and J. C. Simons Jr	86
Basic Techniques in Design and Construction of the Vacuum Plant—F. C. Brown	89
High Vacuum Pumping Techniques—N. Beecher and M. P. Hnilicka	94
Effect of Cooling Diffuser Walls on Performance of a Mercury Vapor Ejector Pump—F. W. Trabert	101
VACUUM INSTRUMENTATION AND CONTROLS;	
EDUCATION IN VACUUM TECHNOLOGY	
A Course in High Vacuum Technology—C. L. Gould	105
An Altitude Chamber Control—K. A. Geiger	110
A New High Frequency Mass Spectrometer and its Use in High Vacuum Technology—K. Diels and H. Moesta	115
A Compensated Thermocouple Vacuum Gauge—M. P. Rivera and R. P. Leriche	118
A Pressure-responsive Relay Control Circuit—A. R. Hamilton	123
Silica-glass Helium Leaks as Standards in Leak Detection— R. H. Work	126
Leak Detection Techniques—W. E. Briggs, A. C. Jones and J. A. Roberts	129
ULTRA-HIGH VACUUM	
The Use of Copper Foil Isolation Traps with Ultra-high Vacuum Systems— J. H. Carmichael and W. L. Lange	137
Some Component Designs Permitting Ultra-high Vacuum with Large Oil Diffusion Pumps—N. Milleron	140
The Production and Measurement of Ultra-high Vacuum (10 ⁻⁸ —10 ⁻¹³ mm Hg) —P. A. Redhead	148
A Liquid-helium-cooled Trap for Pumping Gas by Adsorption—J. R. Ullman	*
Gettering Hydrogen at Ultra-low Pressures by Evaporated Metal Coatings— N. Milleron and E. C. Popp	153
Properties and Behavior of Electronic Ultra-high Vacuum Pumps—L. D. Hall	158
*To be published elsewhere in the near future	

Table of Contents

INDUSTRIAL APPLICATIONS AND PROCESSES	
Electron Bombardment Melting—A High Vacuum Technique Applied to Metallurgy—H. R. Smith, Jr., C. D'A. Hunt and C. W. Hanks	164
Skull Furnace Design and Application-G. N. Facaros, D. R. Carnahan and L. M. Bianchi	168
Design Evaluation Considerations for Vacuum Brazing—R. C. Gross	175
A Large High Temperature Vacuum Sintering Furnace—C. B. Sibley	181
Vacuum Stream Degassing Reaches Commercial Acceptance— K. C. Taylor	185
High Temperature Resistance Furnace for Operations at 3000°C—J.M. Dickinson	192
Some Properties of Vacuum Treated Bessemer Steel—A. M. Samarin	198
VACUUM DEPOSITED MAGNETIC AND THIN FILMS	
Introduction to Magnetic Thin Films—F. B. Humphrey, F. W. Reynolds and G. R. Stillwell	204
Magnetic Domain Configurations in Evaporated Films—M. E. Hale	212
A Comparison between the Evaporation Characteristics of a Crucible and a Ring Source—K. H. Behrndt and R. A. Jones	217
On a Contamination Film Formed Prior to the Evaporation of Nickel-iron in a Bell Jar—F. S. Maddocks and K. H. Behrndt	225
A Demountable Glass Vacuum System Using Electron Bombardment in the Vacuum Deposition of Ferromagnetic Films—D. M. Hart	230
Some Aspects of the Vacuum Deposition of Metals in Transistor Fabrication— R. J. Gnaedinger Jr	235
Electron Beam Recording—H. G. Wehe	242
INDUSTRIAL APPLICATIONS AND PROCESSES	
Automatic Liquid Air Distribution for Large Scale High Vacuum Pumping Systems—N. Ochert and T. A. Heppell	247
The Commercial Operation of a High Vacuum Heat Treat Plant—J. B. Merrill	254
Automatic Freeze Drying and its Application to Food Products—K. G. Neumann and G. W. Oetjen	258
Cryopumping for High Vacuum with Low Power—B. M. Bailey and R. L. Chuan	262
Freeze-drying Rates—L. F. Ginnette, R. P. Graham and A. I. Morgan Jr	268
An Extreme Performance Altitude-Temperature Environmental Chamber—W. C. Gates and B. J. Reitzer	274
High Vacuum Technology in a Space Research Laboratory—H. Reich	279